



Attorney Docket SEL 144

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of)
)
Hiroki Adachi)
)
Serial No.: 09/437,649)
)
Filed: November 10, 1999)
)
For: Exposure Device, Exposure Method)
And Method Of Manufacturing)
Semiconductor Device)
)
Art Unit: 2814)
)
Examiner: S. Rao)

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to:
Commissioner for Patents ,
P.O. Box 1450, Alexandria, VA 22313-1450 on
October 6, 2003
(Date of Deposit)

Shannon Wallace

Name of applicant, assignee, or Registered Rep.

Shannon Wallace 10/6/03
Signature Date

AMENDMENT B

Sir:

In response to the Office Action dated June 4, 2003, a one month extension of time being submitted herewith, please amend the above-identified application as follows:

RECEIVED
OCT 17 2003
TECHNOLOGY CENTER 2800